

Spin Coating Method

ABSTRACT

It is an objective of the present invention to reduce or
5 prevent incorporation of bubbles into a coating film formed by
spin coating a surface of a substrate with a coating liquid having
a high viscosity at a relatively high discharging velocity.

The spin coating method relating to the present invention
comprises the steps of discharging a coating liquid from the
10 tip of a nozzle and dropping onto a surface of a rotating
substrate to form a uniform coating film on the surface of the
substrate, characterized in that the distance between the tip
of the nozzle and the surface of the substrate during discharging
the coating liquid is 2.5 mm or less.

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Fig. 1